

10/530704

Examiner: VALONE, THOMAS

GAU: 2858

Classification: 324/627.000


Inventor: WU, WEI

Status: 71 - RESPONSE TO NON-FINAL OFFICE ACTION ENTERED AND FORWARDED TO EXAMINER

Title: EMI MEASURING METHOD AND ITS SYSTEM

Bib Data report

Application Title: EMI MEASURING METHOD AND ITS SYSTEM

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Examiner: 74005 VALONE, THOMAS (Assignment Data) **Group Art Unit:**
2858 **Class/Subclass:** 324/627.000

State or Country: CHINA **Sheets/Drawing:** 5 **Total Claims:** 15
Independent Claims: 2

Inventors:

Last name, First name:	City:	Country or State:
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Attorneys: ALL **Attorney Docket No:** 6187-000001/US

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